

Static Elimination Characteristics of BF-OHP3B

2011.7.1

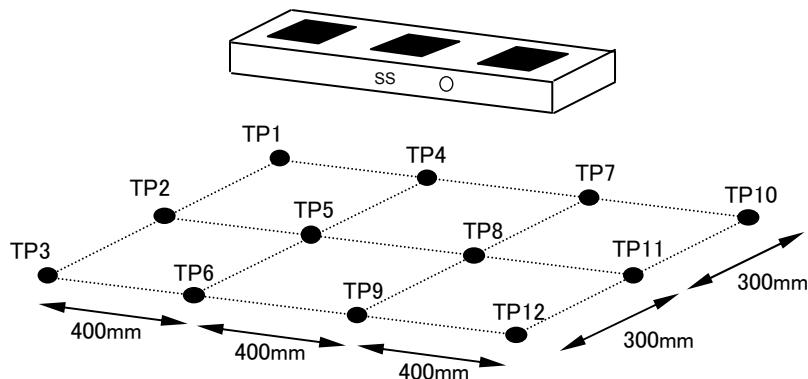


Fig1. Measuring point

Measuring method:

The offset voltage and the decay time to plate voltage from $\pm 1000V$ to $\pm 100V$ are measured in 12 points of the bottom 500mm (1000mm, or 1500mm) plane of an ionizer center at maximum flow by the standard (EOS/ESD S 3.1-1991) of the U.S.

Table1. Static Elimination Characteristics of distance 500mm

Measuring point	TP1	TP2	TP3	TP4	TP5	TP6	TP7	TP8	TP9	TP10	TP11	TP12
Offset voltage [V]	0	-3	-2	0	-3	-2	1	0	1	0	0	1
+Decay time [sec]	36.6	3.8	12.5	5.4	2.2	4.8	5.4	2.1	4.7	16.2	3.9	24.8
-Decay time [sec]	59.5	5.4	19.8	7.7	2.9	6.6	6.0	2.7	7.2	27.4	5.0	31.9

Table2. Static Elimination Characteristics of distance 1000mm

Measuring point	TP1	TP2	TP3	TP4	TP5	TP6	TP7	TP8	TP9	TP10	TP11	TP12
Offset voltage [V]	0	0	0	0	0	0	1	2	1	0	0	0
+Decay time [sec]	16.9	15.0	15.9	8.1	6.9	8.1	9.0	6.4	7.5	14.1	9.6	12.2
-Decay time [sec]	21.4	15.6	19.1	10.6	9.4	13.1	11.8	9.1	9.5	22.7	13.2	15.5

Table3. Static Elimination Characteristics of distance 1500mm

Measuring point	TP1	TP2	TP3	TP4	TP5	TP6	TP7	TP8	TP9	TP10	TP11	TP12
Offset voltage [V]	0	0	0	0	0	0	0	0	0	0	0	0
+Decay time [sec]	18.3	17.2	21.0	13.1	10.4	14.0	13.2	11.6	12.5	26.5	23.5	21.7
-Decay time [sec]	24.5	23.3	29.4	17.4	15.3	18.5	23.5	16.7	17.1	33.3	28.0	26.8

The above-mentioned data does not guarantee a characteristic value.

Some difference occur by environment, an individual difference, or aging.



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